

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Hiroyuki Nishi et al.

Docket No.
SKI.007DSerial No.
09/893,455Filing Date
June 29, 2001Examiner
A. OrtizGroup Art Unit
1732

Invention: TRANSFER MOLDING METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES

TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	12 -	20 =	0	x \$18.00	\$0.00
INDEP. CLAIMS	4 -	4 =	0	x \$86.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

No additional fee is required for amendment.

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Signature

Dated: February 5, 2004

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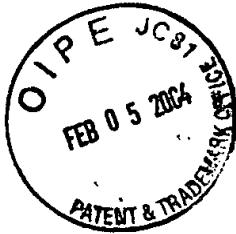
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Serial No. 09/893,455
SKI.007D
Amendment dated February 5, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Hiroyuki Nishi et al.

Group Art Unit: 1732

Serial No.: 09/893,455

Examiner: A. Ortiz

Filed: June 29, 2001

Confirm. No.: 7179

For: TRANSFER MOLDING METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICES

AMENDMENT UNDER 37 C.F.R. 1.116

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Date: February 5, 2004

Sir:

In response to the Final Office Action dated November 6, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.